



2822  
\$

UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yeong-Kwan KIM, et al.

Art Unit: 2822

Serial No. 09/902,607

Examiner: Toniae M. THOMAS

Filed: July 12, 2001

Confirmation No. 1299

For: SEMICONDUCTOR DEVICE HAVING  
THIN FILM FORMED BY ATOMIC LAYER  
DEPOSITION AND METHOD FOR  
FABRICATING THE SAME

Attorney Docket No. 249/258

AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents  
United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

REC  
FEB 17 2004

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action mailed November 5, 2003, please amend the application identified above as follows: